



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 17, 2026

IGI Report Number
Description
Shape and Cutting Style
Measurements

LG839675871
LABORATORY GROWN DIAMOND
ROUND BRILLIANT
10.24 - 10.26 X 6.21 MM

GRADING RESULTS

Carat Weight
Color Grade
Clarity Grade
Cut Grade

4.09 CARATS
I
VVS 2
IDEAL

ADDITIONAL GRADING INFORMATION

Polish
Symmetry
Fluorescence
Inscription(s)

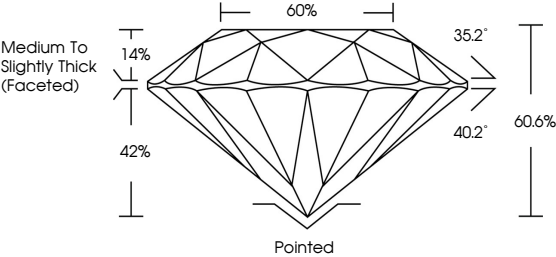
EXCELLENT
EXCELLENT
NONE
IGI LG839675871

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

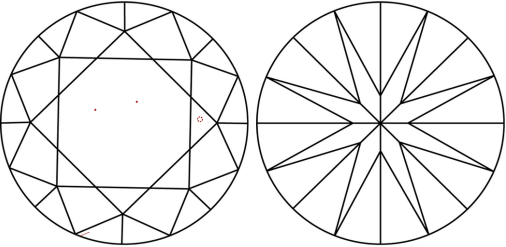
LG839675871

Report verification at igi.org

PROPORTIONS

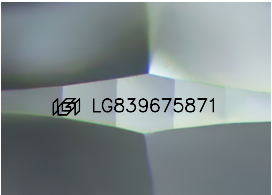


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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4.09 CARATS
I
VVS 2
IDEAL

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Polish
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EXCELLENT
EXCELLENT
NONE
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IGI

September 17, 2026
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ROUND BRILLIANT

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4.09 CARATS
Color Grade
Clarity Grade
Depth
Table
Girdle

I
VVS 2
IDEAL
60.6%
Medium To Slightly Thick (Faceted)

Pointed
EXCELLENT
EXCELLENT
NONE
IGI LG839675871

Culet
Polish
Symmetry
Fluorescence
Inscriptions(s)

None
EXCELLENT
EXCELLENT
NONE
IGI LG839675871

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Type IIa